

Attorney Docket No. 071469-0305917
Client Reference: RAJ-013

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: NORIAKI FUKIAGE, KATHERINA BABICH

Application No.: Confirmation
No:
Filed: November 6, 2003 Group No.:
Examiner
For: METHOD FOR DEPOSITING MATERIALS ON A SUBSTRATE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: NORIAKI FUKIAGE
Citizenship: JAPAN
Residence: Hartsdale, NY

Second applicant: KATHERINA BABICH
Citizenship: USA
Residence: Chappaqua, NY

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD FOR DEPOSITING MATERIALS ON A SUBSTRATE

Docket number assigned to this application: 071469-0305917

Suggested Classification: Class:
Subclass:
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 7

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

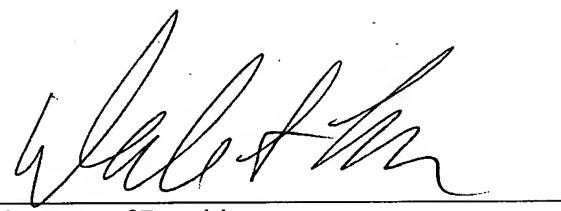
Tokyo Electron Limited
3-6, Akasaka 5-chome, Minato-ku
Tokyo, 107
JAPAN

Extent of interest of assignee in application: 50%

International Business Machines Corporation
New Orchard Road
Armonk, NY 10504
Extent of interest of assignee in application: 50%

Date: November 6, 2003

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Signature of Practitioner

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